

GAU 1765 \$
PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of:

Julia S. SVIRCHEVSKI et al.

Application No. 09/336,401

Filed: June 18, 1999

For: POST-PLASMA PROCESSING WAFER
CLEANING METHOD AND SYSTEM



Attorney Docket No. LAM1P109

Examiner: L. Umez-Eronini

Group Art Unit: 1765

Date: November 27, 2000

CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail to: Assistant Commissioner for Patents, Washington, DC 20231 on November 27, 2000.

Signed:

Peter B. Martine

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Assistant Commissioner for Patents
Washington, DC 20231

Sir:

Applicants transmit herewith an amendment in the above-identified application.

The fee has been calculated as shown below.

	Claims Remaining After Amendment	Highest Previously Paid For	Present Extra	SMALL ENTITY RATE FEE	OR	LARGE ENTITY RATE FEE
TOTAL CLAIMS	22 -	24	00	X09 = \$	OR	X18 = \$
INDEP CLAIMS	03 -	03	00	X40 = \$	OR	X80 = \$
TOTAL				\$		\$0



Applicants hereby petition for a one-month extension of time to respond to the Office Action. Applicants believe that no additional Extension of Time is required; however, if it is determined that such an extension is required, Applicants hereby petition that such an extension be granted and authorize the Commissioner to charge the required fees for an Extension of Time under 37 CFR 1.136 to Deposit Account No. 50-0805.



Enclosed is our Check No. 4508 in the amount of \$110.00 to cover the extension of time fee. If the required fees are missing or any additional fees are required to facilitate filing the enclosed response, then please charge such fees or credit any overpayment to Deposit Account No. 50-0805 (Order No. LAM1P109). A copy of this sheet is enclosed.

Respectfully submitted,
MARTINE PENILLA & KIM, LLP

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